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LIST OF	RENCES CITED BY AF								
				Kentarou TAMAKI, et al. FILING DATE		GROUP			
				September 22, 2005		2874			
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	AW	Kentarou TAMAKI, et al. " Photolithographic Properties of Photosensitive Sol-gel Materials and their Application to Optical Waveguides", Journal of Photopolymer Science and Technology Volume 15, Number 1, 2002, Pages 103-108							
	AX								
	AY				***************************************				
	AZ				Additional References sheet(s) attached				
Examiner					Date Co	Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									